Compton laser options

Ciprian Gal

Center for Frontiers in Nuclear Science * Stony Brook University



Compton scattering basics



- Polarized photon-electron scattering
- Fully QED calculable analyzing power
- Potential to measure redundantly with scattered photon and electron
- Interactions happen with a small fraction of the beam particles leaving it undisturbed
 - Monitoring can be performed in real time during actual data taking



 For both the longitudinal and transverse polarimetry measurements at the at the energies of interested for the EIC the analyzing powers are significant

 $E_{\gamma}^{
m max} = 4 a E_{
m laser} \gamma^2, \qquad
ho = E_{\gamma} / E_{\gamma}^{
m max}$

Longitudinal vs transverse

$$A_{\text{long}} = \frac{\sigma^{++} - \sigma^{-+}}{\sigma^{++} + \sigma^{-+}} = \frac{2\pi r_o^2 a}{(d\sigma/d\rho)} (1 - \rho(1+a)) \left[1 - \frac{1}{(1 - \rho(1-a))^2} \right] \overset{\text{gs}}{\checkmark}$$

$$A_{\text{tran}} = \frac{2\pi r_o^2 a}{(d\sigma/d\rho)} \cos \phi \left[\rho(1-a) \frac{\sqrt{4a\rho(1-\rho)}}{(1 - \rho(1-a))} \right] \overset{\text{os}}{\underset{\text{os}}{\checkmark}} \overset{\text{ss}}{=} \frac{\text{ss}}{\text{ss2nm las}}$$

• While both cases have dependence on energy the transverse also has an azimuthal dependence



0.7 0.6 0.5 0.4 0.3

0.2

-0.1

0.1

0.2

0.3

0.4

0.5

O

0.6

0.7

0.8

0.9



- The energy in the photon detector can measured with calorimetry while the electron is momentum-analyzed by a dipole after the interaction
 - No transverse differences exist for the photon
- Allows for relatively simple analysis of multi-particle crossing

Transverse polarization







- Asymmetry is usually measured with respect to the vertical axis
 - The scattered electron reaches the largest analyzing power at large scattering angles
- The higher the energy the tighter the collimator for the scattered photons will be
 - This leads to significant constraints on detector segmentation

Wavelength dependence for analyzing power

naximum A_{trans}

- The maximum analyzing power increases with lower laser wavelength reaching a peak close to 100nm
- Additionally we can see the position of peak gets further spread out allowing for easier detection
- The longitudinal analyzing power shows similar behaviour, just on a different scale



Lasers as a function of wavelength

- When looking for a laser we need to take into account ease of setup and reliability
 - There is a good reason most Compton polarimeters used Nd:YAG lasers at their core
 - A low power Nd:YAG laser can be amplified quite readily to larger powers without much custom equipment
- Additionally we need to make sure we can have enough power from the laser to provide sufficient luminosity (few Watts of power will be needed)

* Stony Brook University

Compton polarimeters through history

Polarimeter	Energy	Total Sys. Uncertainty	Type of laser	Measurement type
CERN LEP (T)	46 GeV	5%	~10s Hz pulsed Nd:YAG (532nm): 50 -100 W	Multi-photon
HERA (T)	27 GeV	1.9%	CW 10W (514.5nm) Argon	Single-photon
HERA (L)	27 GeV	1.6%	100Hz pulsed 10W Nd:YAG (532nm)	Single/Multi-photon
HERA (L)	27 GeV	1%	CW cavity 3 kW,	Single-photon
SLD at SLAC (L)	45.6 GeV	0.5%	17 Hz pulsed ?? W Nd:YAG (532nm)	Multi-photon
JLab Hall A (L)	1-6 GeV	1-3%	CW cavity 3.7 kW Nd:YAG (532nm)	Single/Multi-photon
JLab Hall C (L)	1.1 GeV	0.6%	CW cavity 1.7 kW Nd:YAG (532nm)	Single/Multi-photon

- Beyond LEP there were quite a few transverse polarimeters around the world that were used for beam diagnostics (an absolute polarization was not in the plan)
- Longitudinal polarimeters are easier to calibration due to the Compton edge and the Ocrossing, making the data easier to analyze
- Pulsed lasers generally tend to give more interactions per crossing so a multi-photon (or integrating) method was employed

M. Woods: (https://www.jlab.org/polarimetry/talks/woods_sld.pdf)

SLD laser setup

- The laser setup for most Compton polarimeters is fairly standard
- Beyond reaching the needed luminosity the laser needs to be circularly polarized at the IP
 - Pockels cells in combination with quarter or half wave plates allow for an arbitrary laser configuration setup (to compensate for any distortions before the IP)
- Polarization and intensity monitoring is setup to ensure reliable operation



M. Woods arXiv:hep-ex/9611005v1



DOCP through windows

- Tests done with cavity at JLab showed that large differences in the degree of circular polarization can be obtained when straining the windows
- Typically the polarization is monitored through measurements of the transmitted laser light (after the IP)
- The "transfer function" can be measured on the bench but variations (such as tightening bolts or pulling vacuum) change the function making it unusable for the actual data taking



JLab Compton polarimetry

- In order to obtain circular polarization in the cavity one can use the information obtained from the back-reflected light
 - In this case it would be off of mirror M1
- Using the optical reversibility theorem one can relate the amount of light reaching "PS" to the degree of circular polarization inside the cavity
 - M. Dalton and D. Jones showed this to be true in a setup at JLab
- By performing detailed scans of the half and quarter wave plates one can maximize the circular light at the IP and monitor it throughout the data taking



HERA (T)



- 200m transport Laser-Lab to IP
- Chopper used for making background measurement
- Measurement extracted from an up-down energy asymmetry
- Leading systematic was related to the detector
 - Systematics for laser were under control
- Background measurements (and simulation cross checks) are very important to reach high precision
 - Beyond Compton scattering we need to measure beam only and laser "only" backgrounds







Laser requirements for the EIC

- At 18 GeV bunches will be replaced every 2 min
 - polarimetry measurement needs to happen in a shorter time span
- The amount of electrons per bunch is fairly small ~24 nC
 - will need bright laser beam to obtain needed luminosity
- Distance between buckets is ~10ns (@5,12 GeV)
 - bunch by bunch measurement cannot be done with a CW laser without very fast detectors
- As we heard from other talks through the workshop a fast polarimeter will allow for faster machine setup
- In order to allow us to have a flexible system we would like to have the ability to vary the frequency of the laser system to be able to measure a single bunch (~78kHz) to interactions with all 1160 bunches at 10 and 5 GeV



Luminosity calculations

$$\mathscr{L} = f_0 N_1 N_2 \frac{\cos(\theta/2)}{2\pi} \frac{1}{\sqrt{(\sigma_{x,1}^2 + \sigma_{x,2}^2)}} >$$



 $\quad \frac{1}{\sqrt{\left(\sigma_{y,1}^2 + \sigma_{y,2}^2\right)\cos^2\left(\theta/2\right) + \left(\sigma_{z,1}^2 + \sigma_{z,2}^2\right)\sin^2\left(\theta/2\right)}}}$ (1) S. Verdu-Andres (CAD): https://www.bnl.gov/isd/documents/95396.pdf

- The dependence of the luminosity of crossing angle needs to take into account the transverse profile of the beam and the length of the pulse
- The estimation on the left is made for a single pulse
- For a 10W 100MHz pulsed laser with a 12ps pulse can provide about 6*10⁵ 1/(barn*s) of luminosity



Luminosity calculations

Configuration	Beam energy [GeV]	Unpol Xsec[barn]	А	A^2	L	1/t(1%)	t[s]	t[min]
laser:532nm, photon	18	0.432	0.072	5.18E-03	1.81E+05	2.93E-02	34	0.57
laser:532nm, electron	18	0.432	0.075	5.63E-03	1.81E+05	3.18E-02	31	0.52
laser:1064nm, photon	18	0.333	0.046	2.12E-03	2.35E+05	1.20E-02	84	1.39
laser:1064nm, electron	18	0.333	0.046	2.12E-03	2.35E+05	1.20E-02	84	1.39

$$N_{Compton} = \frac{\mathcal{L} \cdot \sigma_{unpol}}{f_{beam}}$$

$$t_{meth} = \left(\mathcal{L} \ \sigma_{
m Compton} \ P_{
m e}^2 P_{\gamma}^2 \ \left(\frac{\Delta P_{
m e}}{P_{
m e}} \right)^2 \ A_{
m meth}^2
ight)^{-1}$$

G. Bardin, et al., Conceptual design report of a compton polarimeter in cebaf hall a, JLab Internal note.



- Assuming one scattered particle per bunch would allow us to calculate the luminosity needed and a time estimate for how long it would take to reach a 1% statistical precision
- For all configurations envisioned for the EIC (5-18 GeV) the luminosity requirements are on the level of few 1/(barn*s)
 - Comparing this to the estimate for the 10W laser proves that such a laser will be sufficient
- The times needed to the needed statistics for the signal are on the level 30s at 18 GeV
 - Lower energies are less of a concern due to the longer lived stores
 - This would allow for simultaneous measurement of all bunches

Current design of EIC laser system



- The initial laser system design uses most of the design features highlighted in the previous Compton polarimeter implementations
 - As was before we need the laser system to be away from potential fatal radiation fields inside the tunnel (we plan to evaluate the use of high power laser fiber)
- The vacuum resident insertable mirror will be needed in order to be able to monitor the DOCP at the interaction point

Gain switched seed

- The gain switched seed laser design developed at CEBAF for the injector satisfies all the requirements that we discussed so far
 - The RF lock allows us to synchronize to all or specific electron bunches
 - The pulse longitudinal width will be smaller than the electron bunch (allowing us to potentially measure the longitudinal polarization profile)
 - The PPLN or LBO crystal will allow us to frequency double the 1064nm light to 532
- The system has proven to be very reliable and has been adopted by other facilities (such as the Maintz Microtron)



Phys. Rev. ST Accel. Beams 9, 063501 (2006) https://journals.aps.org/prab/pdf/10.1103/PhysRevSTAB.9.063501



Current design of EIC laser system



• The polarization setup for the EIC Compton will follow the same logical reasoning as the Jefferson Lab measurements

Layout at IP12



- As the scattered particles pass through the different magnets the electrons are stretched horizontally
- At the detector plane we can clearly see both the spatial and energy dependence

* Stony Brook University

Ciprian Gal

Envelopes at detector plane



- 18 GeV will provide the most stringent requirements for the photon detector due to the small vertical separation between the two peaks of the asymmetry
- The electrons have a extreme almond shape with a ratio between the horizontal and vertical extent of about 320
 - The momentum analyzed electrons show the peak analyzing power at about 30% of the minimum energy as expected
- A preliminary analysis of the vertex smearing show that the transverse extent of the electron beam will have an important effect by almost doubling the vertical axis



Detector segmentation



Input normalization: 73%

segmentation	Extracted
[um]	normalization
400	30.53
200	75.71
100	73.74
50	73.43
10	73.01
5	73.00

- By segmenting the simulated signal vertically and assigning an arbitrary normalization one can use the unbinned distribution to extract the normalization
- This rough analysis gives us a feel for what the vertical segmentation of the two detectors will need to be
 - For the photon detector a segmentation of better than 200 micron will be needed
 - The electron detector will require a 50 micron or better segmentation



Input normalization: 85%

segmentation	Extracted
[um]	normalization
500	77.7
400	80.4
333.33	82.7
200	84.4
100	85.1
50	85.0

Summary and outlook

- For the EIC we are trying to incorporate all the lessons that were learned at previous facilities
- A single pass 10 W pulsed laser provides enough luminosity to be able to measure bunch by bunch polarizations on the level of minutes with 1% statistical precision
 - At 2min lifetime for 18GeV we can still reach the 1% goal if we consider the luminosity weighted polarization
- Careful analysis needs to be done for the IR location
 - A longitudinal polarimeter seems to more likely there
 - This would provide a significant cross check on the IP12 Transverse polarimeter and we can combine the results (as HERA did)







Backup



5 vs 18 GeV at e det plane



electron polXsec z=25.00 m

electron polXsec z=25.00 m





HERA (T) systematics

Source of Uncertainty	$\delta P/P(\%)$	Class	Comment	S	ource of Uncertainty	$\delta P/P(\%)$	Class	Comment
Description of Photon Generation, IP and Photon Beam Line			Г	Data Calibration				
HERA Beam Optics	0.5	IIId	7 different optics		Absolute Gain	0.3	I I	Beam energy changing with time
Lepton Beam Line	0.5	IId	Mainly beam position			0.0		Channels Up vs Down
Lopton Boom Horizontal Emittanco	0.1	Ша	in quadrupole			0.3		Channels Op vs Down
Leger Deem Line	0.1	IIId			ertical Table Centring	0.1		
Laser Deam Line	0.2			E	Background Subtraction	0.1	I	
Tilt of Distor Dear Filing	0.1		Maatlaa 90 40	F	Fitting Procedure	•		
The of Photon Beam Ellipse	0.1		Mostly $\approx 2^{\circ} - 4^{\circ}$	l N	Jethod Uncertainty	0.5	I I	Covering complete phase space
Photon Plieup: Multi Photon Interaction	0.1				Puolity of Mong		T	MC Statistics, smoothing and
Calorimeter Response		T T	I		quality of Maps	0.2		interpolation
Average Response	0.6	IIu		I.	mpage of Starting Values	0.2	T	
$-\eta(y)$ and $E(y)$	(0.2)		Up and Down channels		inpact of Starting values	0.2		
- Difference converted to non-	(0.2)				P Distance Reconstruction	0.5		Random jumps in data
- Linearity of Calorimeter Response	(0.2)			P	Pedestal Shift Impact	0.5	IId	Global impact estimated from data
- Effective $\eta(y)$ Calibration	(0.5)		Eff. Silicon strip pitch	I	aser Light Properties			
- Horizontal and LR-channels	(0.1)				inear Laser Light Polarisation	0.2	IId	
Response				Г	Frigger Threshold	1		
Energy Resolution	0.7	llu				0.2	111	
- Total Energy Resolution	(0.4)		Fits to Compton edges		stas at low Energies	0.2	110	
- Central spatial Description	(0.2)				Aachine Performance			
- Difference converted to	(0.1)			E	Emittance Reconstruction	0.9	IId	Comparison with expected
- Resolution Correlations	(0.5)		Channels sharing the					emittances
	(0.0)		same shower					
Signal Modelling	0.3	IIu						
- Digitisation	(0.1)							
- Cross Talk and Non-linearity	(0.3)							
Horizontal Beam Position	0.2	IId						

ς	I	Π
J	L	D

Systematic	1992	1993	1994/95	1996	1997/98
Laser Polarization	2.0%	1.0%	0.2%	0.1%	0.1%
Detector Linearity	1.5%	0.6%	0.5%	0.2%	0.2%
Analyzing Power	1.0%	0.6%	0.3%	0.4%	0.4%
Laser Pickup	0.4%	0.2%	0.2%	0.2%	0.2%
Lum-wting Correction	0.2%	1.1%	0.17%	0.16%	0.15%
TOTAL	2.7%	1.7%	0.67%	0.52%	0.52%



Wavelength dependence for longitudinal analyzing power





JLab Compton polarimetry

Source	Uncertainty	$\Delta \mathbf{P}/\mathbf{P}\%$
Laser Polarization	0.18%	0.18
helicity correl. beam	5 nm, 3 nrad	< 0.07
Plane to Plane	secondaries	0.00
magnetic field	$0.0011 { m T}$	0.13
beam energy	$1 { m MeV}$	0.08
detector z position	$1 \mathrm{mm}$	0.03
trigger multiplicity	1-3 plane	0.19
trigger clustering	$1-8 \ {\rm strips}$	0.01
detector tilt (x, y and z)	1 degree	0.06
detector efficiency	0.0 - 1.0	0.1
detector noise	up to 20% of rate	0.1
fringe field	100%	0.05
radiative corrections	20%	0.05
DAQ efficiency correction	40%	0.3
DAQ efficiency ptto-pt.		0.3
Beam vert. pos. variation	$0.5 \mathrm{\ mrad}$	0.2
spin precession in chicane	20 mrad	< 0.03
Electron Detector Total		0.56
Grand Total		0.59



Time for 1% measurements

Assume 1 photon/electron per crossing		Average asymmetry						
Configuration	Beam energy [GeV]	Unpol Xsec[barn]	А	A^2	L	1/t(1%)	t[s]	t[min]
laser:532nm, photon	18	0.432	0.072	5.18E-03	1.81E+05	2.93E-02	34	0.57
laser:532nm, electron	18	0.432	0.075	5.63E-03	1.81E+05	3.18E-02	31	0.52
laser:1064nm, photon	18	0.333	0.046	2.12E-03	2.35E+05	1.20E-02	84	1.39
laser:1064nm, electron	18	0.333	0.046	2.12E-03	2.35E+05	1.20E-02	84	1.39
laser:532nm, photon	5	0.569	0.031	9.61E-04	1.37E+05	5.43E-03	184	3.07
laser:532nm, electron	5	0.569	0.029	8.41E-04	1.37E+05	4.75E-03	210	3.51
laser:1064nm, photon	5	0.339	0.017	2.89E-04	2.31E+05	1.63E-03	613	10.21
laser:1064nm, electron	5	0.339	0.015	2.25E-04	2.31E+05	1.27E-03	787	13.11
laser:532nm, photon	12	0.482	0.057	3.25E-03	1.62E+05	1.84E-02	54	0.91
laser:532nm, electron	12	0.482	0.056	3.14E-03	1.62E+05	1.77E-02	56	0.94
laser:1064nm, photon	12	0.327	0.034	1.12E-03	2.39E+05	6.34E-03	158	2.63
laser:1064nm, electron	12	0.327	0.033	1.10E-03	2.39E+05	6.23E-03	161	2.68

